

# Supporting Information

## Multifunctional and Ultrasensitive rGO and Pen ink/PVA Decorated Model/Spandex Fabric for High-performance Wearable Sensors

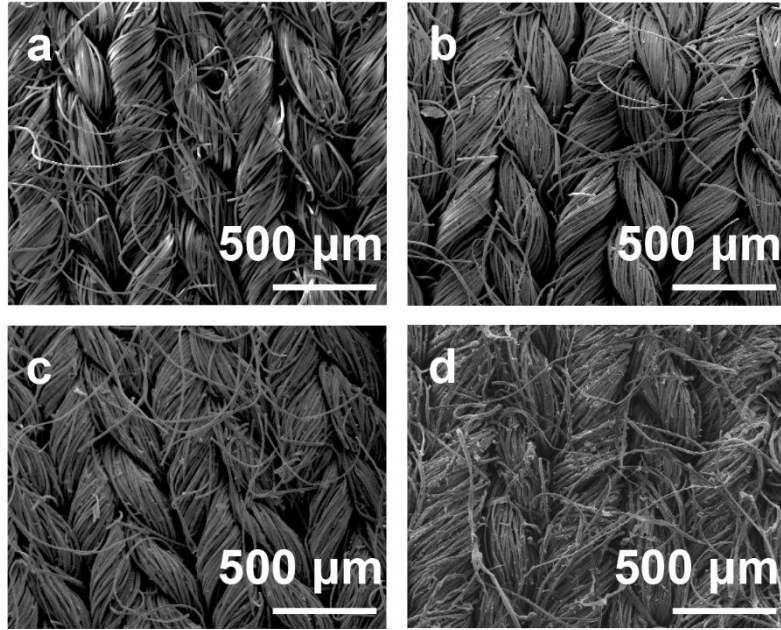
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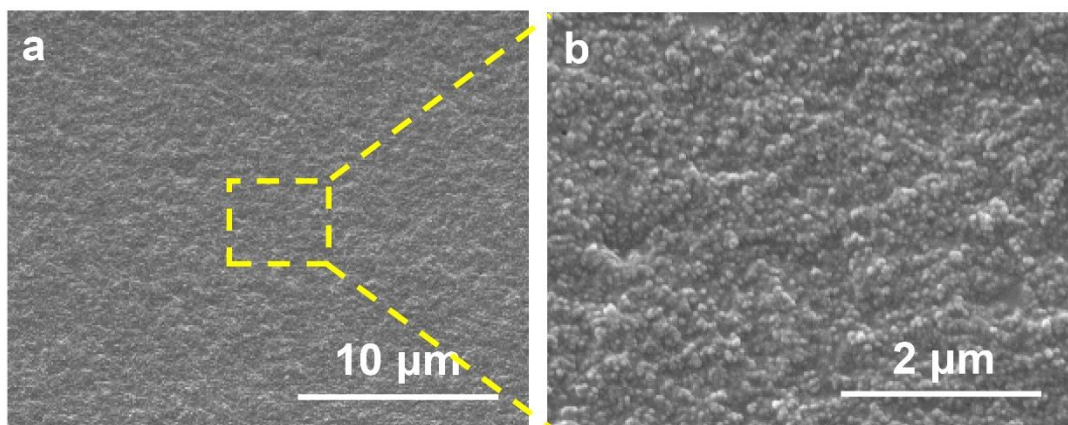
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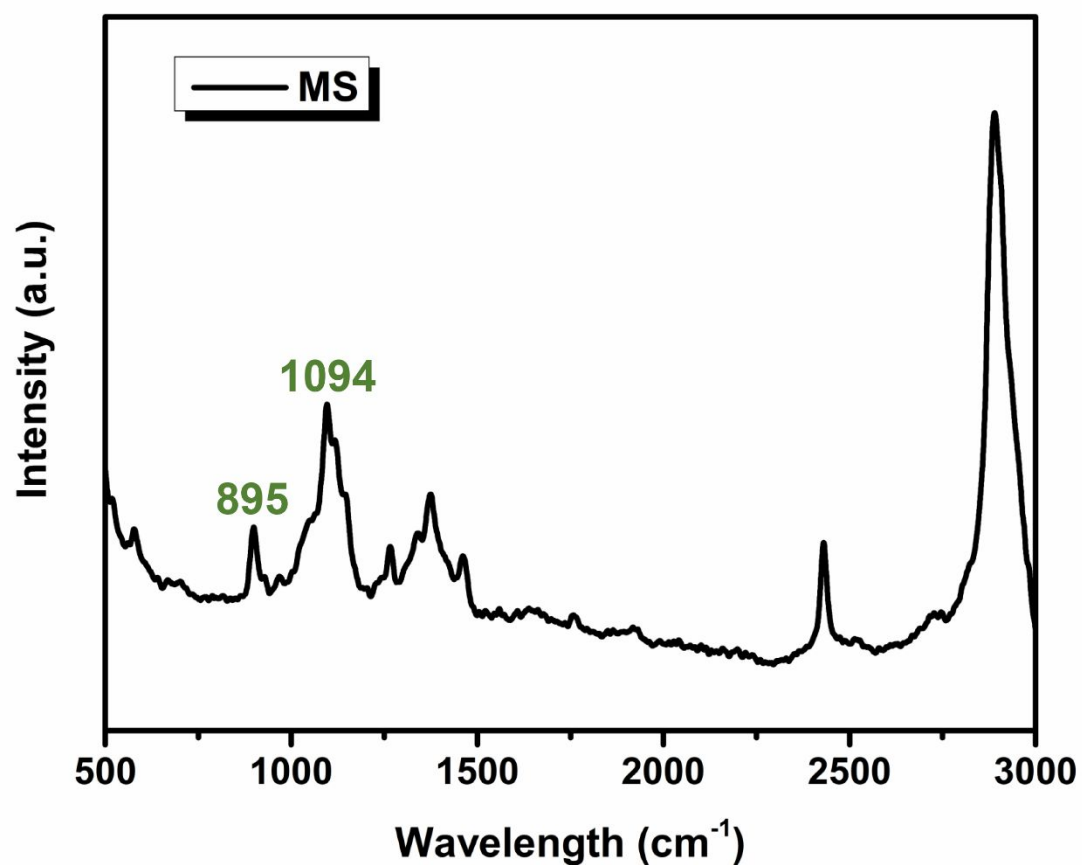
E-mail address: yxlu@fudan.edu.cn



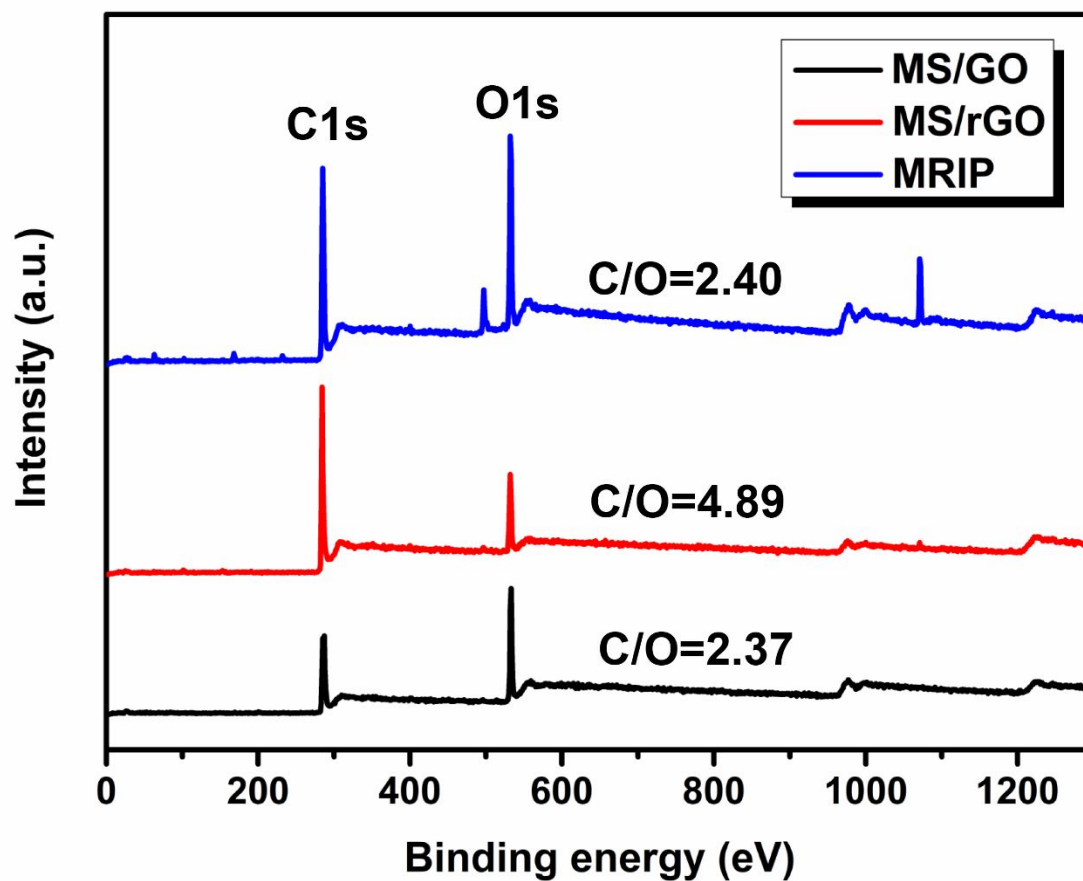
**Figure S1.** a-d) FE-SEM images of MS with different GO concentrations of  $0.5 \text{ mg} \cdot \text{ml}^{-1}$ ,  $1.0 \text{ mg} \cdot \text{ml}^{-1}$ ,  $1.5 \text{ mg} \cdot \text{ml}^{-1}$  and  $2.0 \text{ mg} \cdot \text{ml}^{-1}$ , respectively. The surface of fibers becomes rougher with the increment of GO concentration.



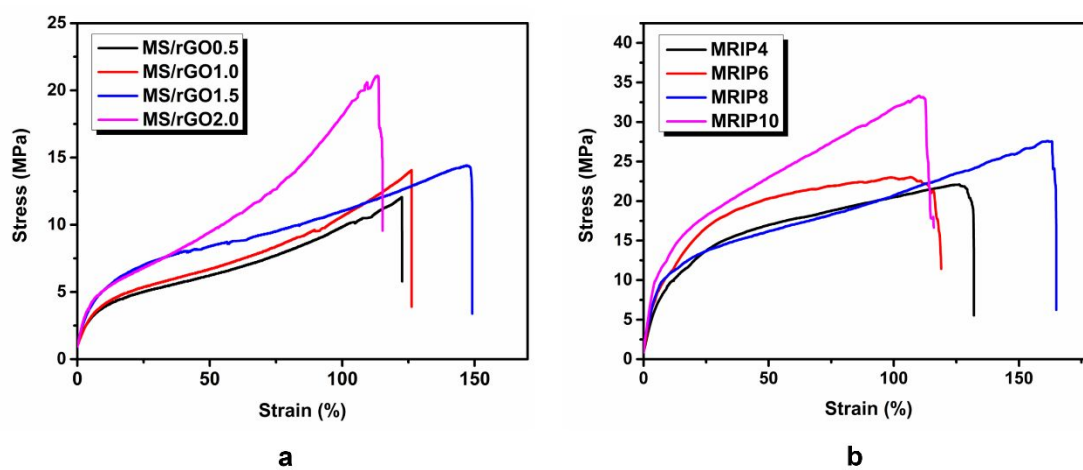
**Figure S2.** a-b) FE-SEM images of MRIP at different magnifications. The surface shows a porous microstructure and gully morphology.



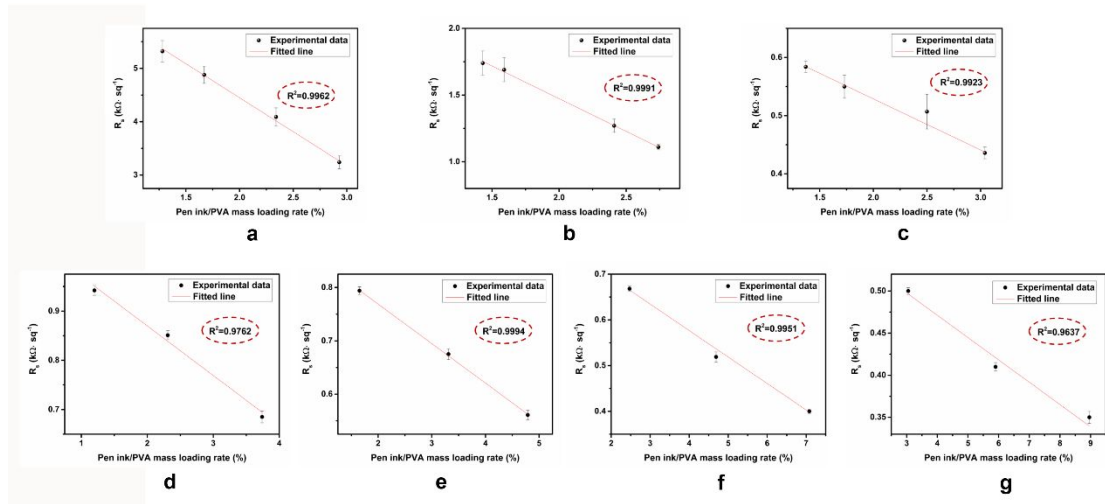
**Figure S3.** Raman spectra of MS. Bands located at about 895  $\text{cm}^{-1}$  and 1094  $\text{cm}^{-1}$  are two characteristic peaks of cellulose, which give rise to cellulose C-O ring stretching and angle bending of mixed modes (C-C-C, C-H-O) respectively.



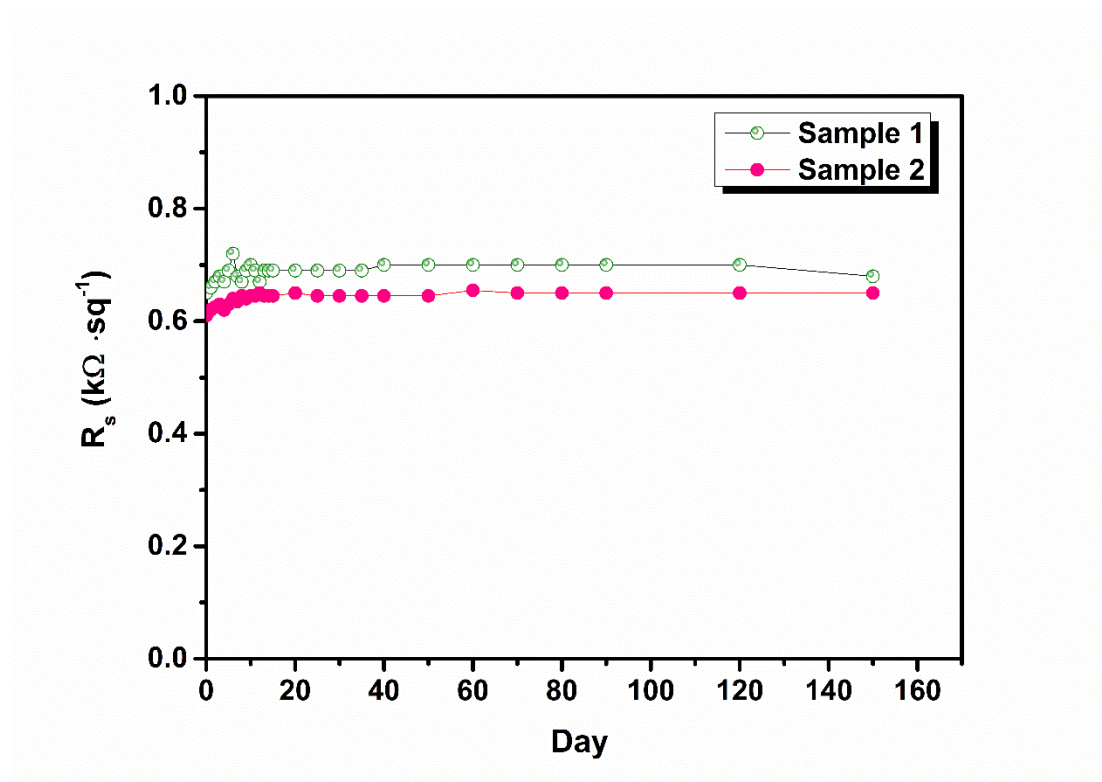
**Figure S4.** XPS spectra of MS/GO1.5, MS/rGO1.5 and MRIP8. The main elements of C and O are obviously seen in XPS survey spectra.



**Figure S5.** a) Stress-strain curve of MS/rGO with different concentrations of GO and  
b) MRIP with different concentrations of carbonic pen ink.

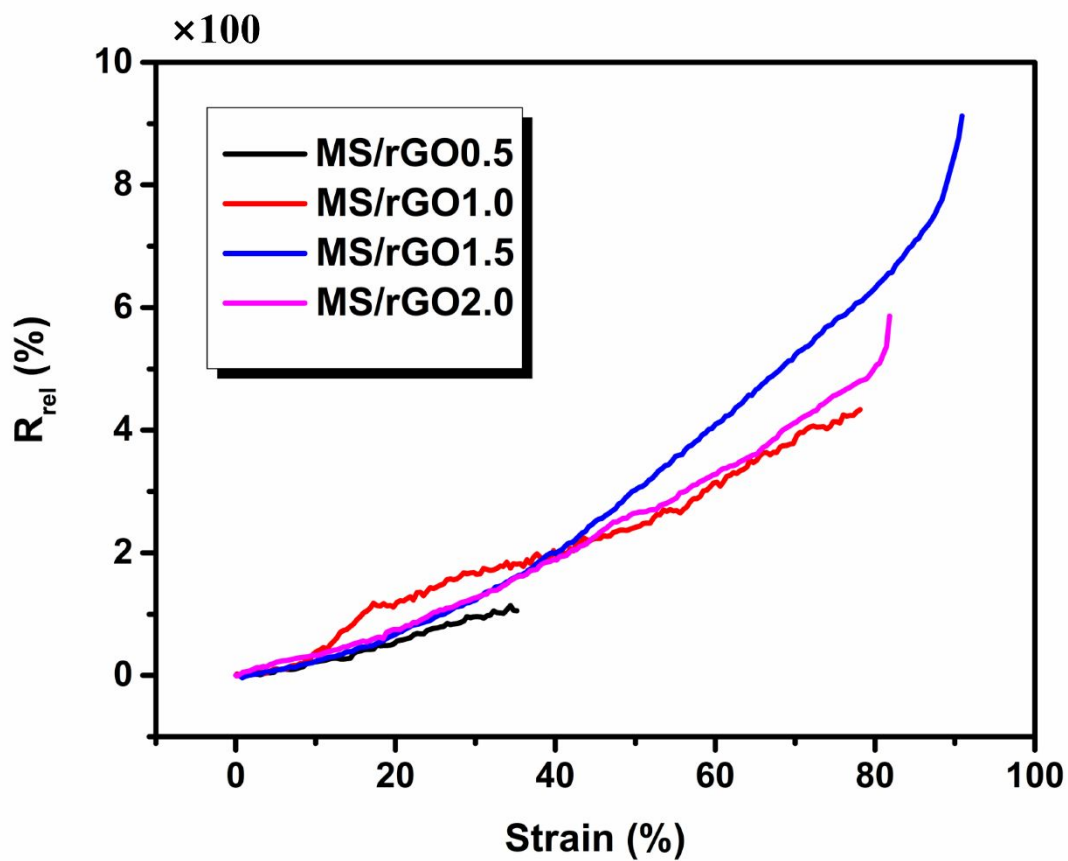


**Figure S6.** Electrical conductivity of MRIP versus pen ink/PVA mass loading rate. Surface resistance variations of MRIP based on MS/rGO0.5 (a), MS/rGO1.0 (b) and MS/rGO2.0 (c) versus pen ink/PVA mass loading rate at different pen ink concentrations of 4 wt.%, 6 wt.%, 8 wt.% and 10 wt.%. Surface resistance variations of MRIP at different pen ink concentrations of 4 wt.% (d), 6 wt.% (e), 8 wt.% (f) and 10 wt.% (g) versus pen ink/PVA mass loading rate by dipping times of 1, 2 and 3 times in pen ink solution.

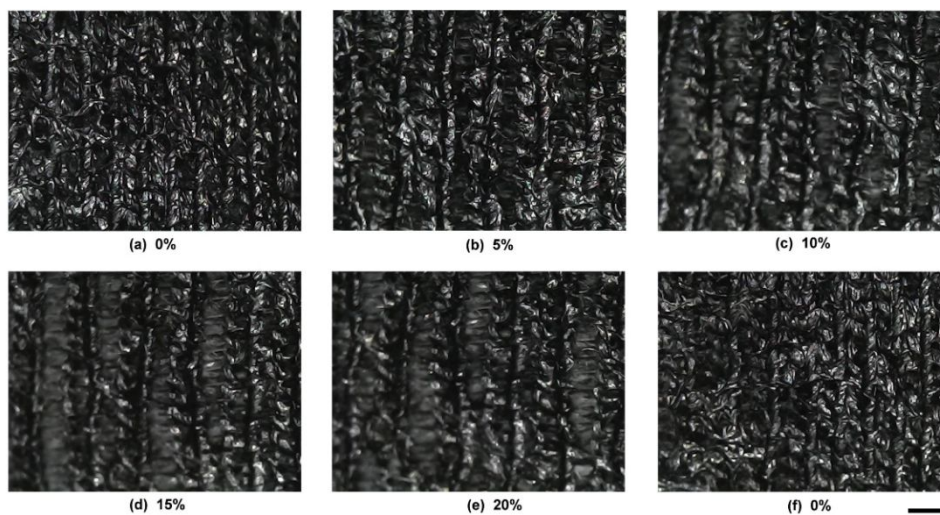


**Figure S7.** Surface resistance variations of two MRIP8 fabric samples within 5 months in ambient environment.

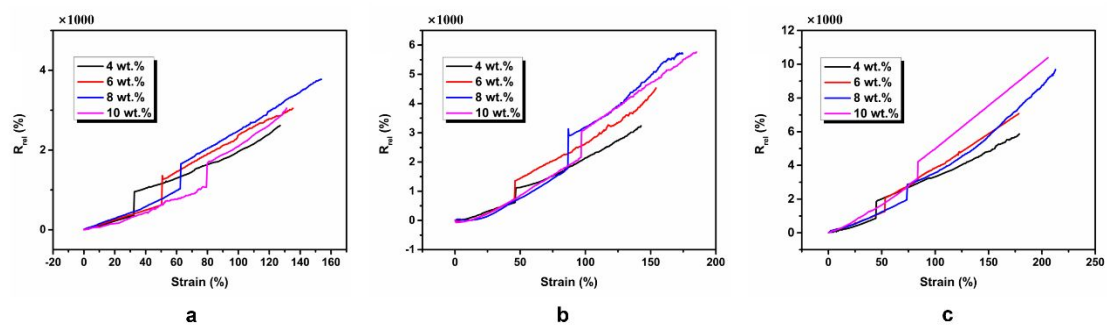




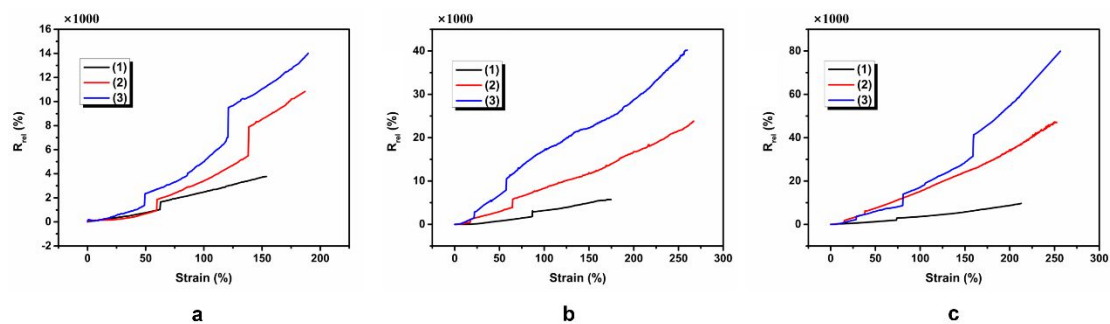
**Figure S8.** Relative resistance variation of MS/rGO0.5, MS/rGO1.0, MS/rGO1.5 and MS/rGO2.0 versus strain, respectively.



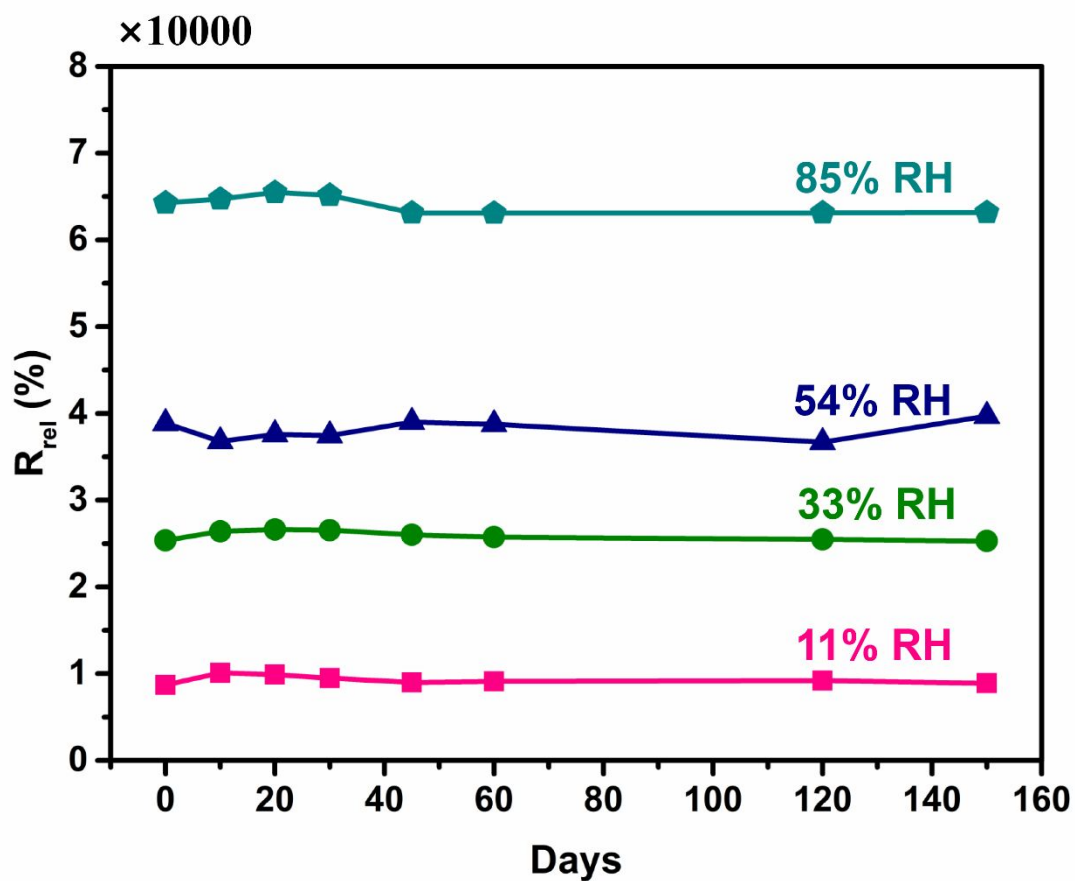
**Figure S9.** The optical images of MRIP under 0%, 5%, 10%, 15%, 20% and 0% strain levels, respectively.



**Figure S10.** Strain sensing performance of MRIP with various pen ink concentrations (4 wt.%, 6 wt.%, 8 wt.% and 10 wt.%) based on MS/rGO0.5 (a), MS/rGO1.0 (b) and MS/rGO2.0 (c), respectively.



**Figure S11.** Relative resistance variation of MRIP with 4 wt.% (a), 6 wt.% (b) and 10 wt.% (c) with different pin ink/PVA layers (one to three dip-coating times) as a function of strain.



**Figure S12.** Long-term stability of MRIP8(3) exposed to various RH conditions within five months.

**Table S1** The GF and sensing range of MRIP

Sample	Stage	GF	Sensing range (%)
MS/rGO0.5	1	3.4	35
MS/rGO1.0	1	5.4	78
MS/rGO1.5	1	9.1	91
MS/rGO2.0	1	6.4	81
MRIP0.5-4	1	11.4	32
	2	17.0	127
MRIP0.5-6	1	12.3	50
	2	21.6	135
MRIP0.5-8	1	15.9	62
	2	23.7	154
MRIP0.5-10	1	14.2	79
	2	25.6	131
MRIP1.0-4	1	14.6	46
	2	22.9	143
MRIP1.0-6	1	17.8	46
	2	27.6	154
MRIP1.0-8	1	22.0	87
	2	35.4	175
MRIP1.0-10	1	24.5	97
	2	31.3	185

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MRIP1.5-4	1	18.2	42
	2	48.5	154
MRIP1.5-6	1	26.8	43
	2	71.0	158
MRIP1.5-8	1	36.9	67
	2	100.9	293
MRIP1.5-10	1	31.6	79
	2	81.0	293
MRIP2.0-4	1	19.1	45
	2	29.1	179
MRIP2.0-6	1	23.0	53
	2	40.4	178
MRIP2.0-8	1	26.5	74
	2	49.6	213
MRIP2.0-10	1	38.8	83
	2	50.9	206
MRIP0.5-8-2 <sup>□</sup>	1	13.6	59
	2	46.2	138
	3	62.0	187
MRIP0.5-8-3	1	26.2	49
	2	63.9	121
	3	63.8	190

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MRIP1.0-8-2	1	30.8	17
	2	58.4	64
	3	86.8	267
MRIP1.0-8-3	1	71.3	22
	2	141.4	58
	3	134.0	295
MRIP1.5-8-2	1	179.0	49
	2	212.5	132
	3	264.6	300
MRIP1.5-8-3	1	213.0	33
	2	315.1	84
	3	492.8	300
MRIP2.0-8-2	1	45.8	15
	2	126.0	38
	3	191.1	267
MRIP2.0-8-3	1	83.4	28
	2	98.1	81
	3	221.1	159
		407.0	267

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□The first number means the concentration of GO, the second number means the concentration of pen ink and the third number means the dipping time of pen ink/PVA layer. The concentration of PVA is designed at 1 wt.% for stain sensing measurement.



Table S2

The strain and humidity sensitivities of MRIP after various washing procedures.

Washing cycles	Maximum Strain sensitivity	Humidity sensitivity
0	492.8	765.1
1	487.9	771.3
2	481.2	776.6
3	474.3	780.4
6	495.7	781.1
9	486.8	769.2
12	467.5	754.9

Table S3

The permeability of MRIP.

Sample	Permeability (mm/s)
MS	$986.94 \pm 15.983$
MRIP8	$787.65 \pm 20.465$
MRIP8(2)	$535.96 \pm 22.017$
MRIP8(3)	$353.28 \pm 18.214$